

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of:	Attorney Docket No. 029567-00011
Makiko KITAZOE, et al.	Confirmation No.: 8995
Serial No.: 10/593444	Art Unit: 1792
Filed: February 5, 2007	Examiner: Joseph Albert MILLER, Jr.
For:	UNIT-LAYER POST-PROCESSING CATALYST CHEMICAL-VAPOR DEPOSITION APPARATUS AND ITS FILM FORMING METHOD

**RESPONSE UNDER 37 C.F.R. §1.111**

**Mail Stop AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**August 4, 2009**

Sir:

In reply to the outstanding Office Action dated March 5, 2009, please amend the application as shown on the following pages. The period for response is extended two (2) months, from June 5, 2009 to August 5, 2009. The two month extension of time fee is being submitted herewith via EFS.

**Amendments to the Specification** begin on page 2.

**Amendments to the Claims** begin on page 7.

**Remarks** begin on page 12.

**Conclusion** begins on page 17.